

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
SHIMIN GE	11/15/2016
HEJING ZHANG	11/15/2016
CHIHYUAN TSENG	11/15/2016
CHIHYU SU	11/15/2016
WENHUI LI	11/15/2016
LONGQIANG SHI	11/15/2016
XIAOWEN LV	11/15/2016
RECEIVING PARTY DATA	
Name:	SHENZHEN CHINA STAR OPTOELECTRONICS TECHNOLOGY CO., LTD.
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City:	SHENZHEN CITY, GUANGDONG
State/Country:	CHINA
Postal Code:	518132
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	15365956
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SIGNATURE:	/Leong C. Lei/
DATE SIGNED:	12/01/2016

PATENT

This document serves as an Oath/Declaration (37 CFR 1.63).

Total Attachments: 3

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Combined Declaration and Assignment for Patent Application

Title of the Invention: MANUFACTURE METHOD OF DUAL GATE
OXIDE SEMICONDUCTOR TFT SUBSTRATE AND STRUCTURE THEREOF

As a below named inventor, I hereby declare that:

This declaration is directed to:

- The attached application, or
- U.S. Application Number or PCT International Application Number 14/763,823
filed on 07/28/2015

The above-identified application was made or authorized to be made by me.

I believe I am the original inventor or an original joint inventor of a claimed invention in the application.

I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.

ASSIGNMENT

This assignment agreement is applicable to an invention entitled (Invention Title) MANUFACTURE

METHOD OF DUAL GATE OXIDE SEMICONDUCTOR TFT SUBSTRATE AND STRUCTURE THEREOF

The PATENT RIGHTS referred to in this agreement are:

(check one) a patent application for this invention, executed by the ASSIGNOR(S) concurrently with this assignment.

- U.S. patent application Serial No. _____, filed _____.
- U.S. patent No. _____, issued _____.

The PATENT RIGHTS also include all divisions, reissues, continuations and extensions of the patents and patent applications identified above.

The PATENT RIGHTS assigned under this agreement are:

(check one) U.S. patent rights only.
 worldwide patent rights. In this case, the assignee shall have the right to claim the benefit of the filing date of any U.S. patent application identified above.

The ASSIGNOR(S) referred to in this agreement is (or are):

(check one) Inventor(s)
 Present Owner

(Full name of sole or first ASSIGNOR) Shimin Ge
(Address) NO.9-2, Tangming Road, Guangming District of Shenzhen, Guangdong 518132, China

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(Full name of eighth joint ASSIGNOR, if any) _____
(Address) _____

(Full name of ninth joint ASSIGNOR, if any) _____
(Address) _____

(Full name of tenth joint ASSIGNOR, if any) _____
(Address) _____

The ASSIGNEE referred to in this agreement is:

(Name of sole or first Assignee) SHENZHEN CHINA STAR OPTOELECTRONICS TECHNOLOGY CO., LTD.
(Address of assignee) NO.9-2, Tangming Road, Guangming District of Shenzhen, Guangdong 518132, China

The sole or first ASSIGNEE is:

(check one) An Individual.
 A Partnership.
 A Corporation of China
(state or country)

The ASSIGNOR(S), in consideration of \$1.00 paid by the ASSIGNEE, and other good and valuable consideration, receipt of which is acknowledged, have and do hereby assign the following to the ASSIGNEE; its successors and assigns:

- the full and exclusive right to the invention;
- the entire right, title and interest in and to the PATENT RIGHTS; and
- the right to claim priority under 35 USC 119, based on any earlier foreign applications for this invention.

As to all U.S. patent applications assigned under this agreement, the ASSIGNOR(S) hereby authorize(s) and request(s) the Commissioner of Patents and Trademarks to issue all Letters Patent to the ASSIGNEE as the assignee of the entire right, title and interest, for the sole use and enjoyment of said ASSIGNEE, its successors and assigns.

Further, the ASSIGNOR(S) agree(s) to communicate to said ASSIGNEE, or its representatives, any facts known w to the ASSIGNOR(S) respecting said invention, and testify in any legal proceedings, sign all lawful papers, execute all divisional, continuation, substitute, renewal, reexamination and reissue applications, execute all necessary assignment papers to cause any and all Letter Patent to be issued to said ASSIGNEE, make all rightful oaths and generally do everything necessary or desirable to aid said ASSIGNEE, its successors and assigns, to obtain and enforce proper protection for said invention.

ASSIGNOR(S) authorize(s) LEONG C. LEI (Reg. No. 50402) to insert or complete any information in this document needed to effect its recordal in the U.S. Patent and Trademark Office.

Shimin Ge
Shimin Ge (Signature of sole or first ASSIGNOR)

2016.11.15
(Date)

Hejing Zhang	<u>Hejing Zhang</u> (Signature of second joint ASSIGNOR)	<u>2016/11/15</u> (Date)
Chihyuan Tseng	<u>Chihyuan Tseng</u> (Signature of third joint ASSIGNOR)	<u>2016/11/15</u> (Date)
Chihyu Su	<u>Chihyu Su</u> (Signature of fourth joint ASSIGNOR)	<u>2016/11/15</u> (Date)
Wenhui Li	<u>Wenhui Li</u> (Signature of fifth joint ASSIGNOR)	<u>2016/11/15</u> (Date)
Longqiang Shi	<u>Longqiang Shi</u> (Signature of sixth joint ASSIGNOR)	<u>2016/11/15</u> (Date)
Xiaowen Lv	<u>Xiaowen Lv</u> (Signature of seventh joint ASSIGNOR)	<u>2016/11/15</u> (Date)
	_____ (Signature of eighth joint ASSIGNOR)	_____ (Date)
	_____ (Signature of ninth joint ASSIGNOR)	_____ (Date)
	_____ (Signature of tenth joint ASSIGNOR)	_____ (Date)